

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
JENS KRAMER, et al.

Serial No.: 10/747,723

Filed: DECEMBER 23, 2003

For: METHOD AND SYSTEM  
FOR CONTROLLING THE CHEMICAL  
MECHANICAL POLISHING BY USING  
A SENSOR SIGNAL OF A PAD  
CONDITIONER

Group Art Unit: 3723

Examiner: Maurina T. Rachuba

Atty. Dkt. No.: 2000.109500

Customer No.: 23720

**RESPONSE TO FINAL OFFICE ACTION DATED MARCH 31, 2006**

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office Final Action dated March 31, 2006 for which the three-month date for response is June 30, 2006.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from WILLIAMS, MORGAN & AMERSON'S P.C. Deposit Account 50-0786/2000.109500.

Reconsideration of the application is respectfully requested.

Do not enter MR 7/27/06